

SEP 14 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/757,253
Confirmation No. 4387
Filing Date January 13, 2004
Inventor Denise M. Eppich
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Hsien-Ming Lee
Attorney's Docket No. MI22-2467
Customer No. 021567
Title: Methods Of Forming Transistor Devices And Capacitor Constructions

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission
2. Response to June 29, 2004 Office Action

Dated: September 14, 2004By: 

Jennifer Gaines, Legal Assistant
Telephone No. (509) 624-4276
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FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: September 14, 2004By: 

David G. Latwesen, Ph.D.
Reg. No. 38,533

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RESPONSE TO JUNE 29, 2004 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

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